



PTO/SB/08A (08-03)

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Sheet	1	of	5
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Application Number	10/567,917
Filing Date	February 6, 2006
First Named Inventor	James R. Link
Art Unit	1763
Examiner Name	Unassigned R. Culbert
Attorney Docket Number	0321.70917

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08/13/2007

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Sheet	2	of	5	Attorney Docket Number	0321.70917

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
/RC/		Y. Xia, J.A. Rogers, K.E. Paul, G. Whitesides, "Unconventional Methods for Fabricating and Patterning Nanostructures", Chem. Rev., 1999, Vol. 99, pp. 1823-48	
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		First Named Inventor	James R. Link		
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		Examiner Name	Unassigned		
Sheet	3	of	5	Attorney Docket Number	0321.70917

NON PATENT LITERATURE DOCUMENTS			
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/RC/		J.R. Link, M.J. Sailor, "Smart Dust: Self-Assembling, Self-Orienting Photonic Crystals of Porous Si", Applied Physical Sciences, Aug. 12, 2003.	
/RC/		X. Xu, S.A. Majetich, S.A. Asher, "Mesoscopic Monodisperse Ferromagnetic Colloids enable Magnetically Controlled Photonic Crystals," J. Am. Chem. Soc., Vol. 124, 2002, 13864-68	
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/RC/		M.G. Berger, R. Arens-Fischer, M. Thoenissen, M. Krueger, S. Billat, H. Lueth, S. Hilbrich, W. Theiss, P. Grosse, "Dielectric Filters Made of PS: Advanced Performance by Oxidation and New Layer Structures," Thin Solid Films, Vol. 297, 1997, pp. 237-240	
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/RC/		L.T. Canham, M.P. Stewart, J.M. Buriak, C.L. Reeves, M. Anderson, E.K. Squire, P. Allcock, P.A. Snow, "Derivatized Porous Silicon Mirrors: Implantable Optical Components with Slow Resorbability," Phys. Stat. Sol. (a), Vol. 182, 2000, pp. 521-525	
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

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/RC/		B. Warneke, M. Last, B. Liebowitz, K.S.J. Pister, "Smart Dust: Communicating with a Cubic Millimeter Computer," IEEE Computer Society, Vol. 34, No. 1, January 2001, pp. 44-51	
/RC/		Y.Y. Li, F. Cunin, J.R. Link, T. Gao, R.E. Betts, S.H. Reiver, V. Chin, S.N. Bhatia, M.J. Sailor, "Polymer Replicas of Photonic Porous Silicon for Sensing and Drug Delivery Applications," Science, Vol. 299, March 28, 2003, pp 2045-47	
/RC/		L.T. Canham, C.L. Reeves, A. Loni, M.R. Houlton, J.P. Newey, A.J. Simons, T.I. Cox, "Calcium Phosphate Nucleation on Porous Silicon: Factors Influencing Kinetics in Acellular Simulated Body Fluids," Thin Solid Films, Vol. 297, 1997, pp. 304-307	

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	Applicant: Link et al.	
	Filing Date: 02/06/2006	Group: 1763

U.S. PATENT DOCUMENTS

Examiner Initial*	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

/RC/	Sailor, M.J., "Properties of Porous Silicon," The Institution of Electrical Engineers, pp. 364-370, August 1997.

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